10576159 - GAU: 2121
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Application Number		10576159
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First Named Inventor ALLC		DN GUEZ
Art Unit		2121
Examiner Name	/Sur	nray R. Chang/ (09/20/2008)
Attorney Docket Numb	er	DREX-1007US

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	2	5761350		1998-06-02	кон	
	3	6003341		1999-12-21	BLOOM	
	4	6016211		2000-01-18	SZYMANSKI	
	5	6164837		2000-12-26	HAAKE	
	6	6237370		2001-05-29	BLOOM	
	7	6363183		2002-03-26	кон	
	8	6430337		2002-08-06	BERGMANN	

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	1	AULT, Stanley K. et al., LEOS Annual Meeting,					luton	nated Packaging	of Pho	tonics Components,"	
	2	BANERJEE, S. Riki and Optoelectronic Array Pa							n Interd	connects for	

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3	GUEZ, Allon et al., "Multiple Objective Optimization Approach to Adaptive and Learning Control," International Journal of Control, 1992, pgs. 489-482, Vol. 56, No. 2. Abstract Only	
4	GUEZ, Alion and SELINSKY, John, "Neurocontroller Design Via Supervised and Unsupervised Learning," Journal of Intelligent and Robotic Systems, 1989, pgs. 307-335, Vol. 2.	
5	JANG, Soon, "Automation Manufacturing Systems Technology for Opto-electronic Device Packaging," 2000 Electronic Components and Technology Conference, 50th Proceedings, 2000, pgs. 10-14.	
6	KURZWEG, Timothy P., "Optical Propagation Methods for System-Level Modeling of Optical MEM Systems," Ph.D. Thesis, University of Pittsburgh, Department of Electrical Engineering, 2002.	
7	KURZWEC, Timothy P. et al., "A Fast Optical Propagation Technique for Modeling Micro-Optical Systems," Proceedings of the 2002 Design Automation Conference, New Orleans, LA, 2002.	
8	KURZWEC, Timothy P. et al., "Modeling Optical MEM Systems," Journal of Modeling and Simulation of Microsystems, 2001, pgs. 21-34, Vol. 2, No. 1.	
9	KURZWEG, Timothy P, and MORRIS III, Arthur S., "Macro-Modeling of Systems Including Free-Space Optical MEMS," Third International Conference on Modeling and Simulation of Microsystems, Semiconductors, Sensors and Actuators (MSM00), San Diego, CA, 2000.	
10	LEVITAN, Steven P. et al., "Chatoyant: A Computer-Aided-Design Tool for Free-Space Optoelectronic Systems," Applied Optics, 1998, pgs. 6078-6092, Vol. 37, No. 26.	
11	LEVITAN, Steven P. et al., "System Simulation of Mixed-Signal Multi-Domain Microsystems with Piecewise Linear Models," IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems, 2003, pgs. 139-154, Vol. 22, No. 2.	
12	MARTINEZ, Jose A. et al., "Mixed-Technology System-Level Simulation," Analog Integrated Circuits and Signal Processing, 2001, pgs. 127-149, Vol. 29.	
13	VELSHER, Ben, "Application-Specific Optoelectronic Packaging," 2002 Electronic Components and Technology Conference, 52nd Proceedings, 2002, pgs. 794-800.	

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /S.C./

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Examiner Name			
Attorney Docket Number		DREX-1007U	6

	14		WU, Ming C., "Micromachining for Optical and Optoelectronic Systems," Proceedings of the IEEE, 1997, pgs. 1833-1856, Vol. 85, No. 11.								
	15		YAMAUCHI, Kenji et al., "Automated Mass Production Line for Optical Module Using Passive Alignment Technique," 2000 Electronic Components and Technology Conference, 50th Proceedings, 2000, pgs. 15-20.								
	16		KURZWEG, Timothy P. et al., "Model Based Opto-Electronic Packaging Automation," IEEE Journal of Selected Topics in Quantum Electronics, 2004, pgs. 445-454, Vol. 10, No. 3.								
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